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Our File No. 9281-4659

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	Application of:	•
Naoya	a Hasegawa et al.)
Serial	No. To be Assigned)
Filing	Date: Herewith)
For	Magnetic Detecting Element Having Antiferromagnetic Film Having Predetermined Space in Track Width Direction and Method for Manufacturing the Same))))

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to the obligation under 37 C.F.R. 1.56 and in conformance with 37 C.F.R. 1.97-1.99, Applicants hereby submit references A1 – A5 listed on the attached form PTO-1449 for consideration by the Examiner. Copies of the references are enclosed herewith.

Japanese Unexamined Patent Application Publication No. 2000-163717 discloses a recessed pinning antiferromagnetic layer. Japanese Unexamined Patent Application Publication No. 2001-256617 and Japanese Unexamined Patent Application Publication No. 2001-13910 each disclose a recessed free antiferromagnetic layer. Japanese Unexamined Patent Application Publication No. 8-7225 discloses a write head comprising a recessed lower core layer.

The filing of this Information Disclosure Statement does not constitute an admission that the information cited herein is, or is considered to be, material to



patentability as defined in 37 C.F.R. Section 1.56(b). Further, Applicants reserve the right to contest these references as prior art against the present application, and Applicants do not believe that the disclosure of these references, even if finally determined to be prior art, anticipates Applicants' invention or that these references make Applicants' invention obvious.

No fees are believed to be due in connection with filing of this Information Disclosure Statement, however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be deemed necessary for any reason relating to this material, the Commissioner is hereby authorized to deduct said fees from Brinks Hofer Gilson & Lione Deposit Account No. 23-1925.

Applicants respectfully request that the Examiner review the entire disclosure of these documents and make them of record.

Respectfully submitted,

Gustavo Siller, Jr.

Registration No. 32,305 Attorney for Applicants

BRINKS HOFER GILSON & LIONE P.O. BOX 10395 CHICAGO, ILLINOIS 60610 (312) 321-4200

FORM PTO-1449	SERIAL NO.		CASE NO.
		To be Assigned	9281-4659
LIST OF PATENTS AND PUBLICATIONS FOR	FILING DATE		GROUP ART UNIT
APPLICANT'S INFORMATION DISCLOSURE		Herewith	
STATEMENT			
(use several sheets if necessary)	APPLICANTS	: Naova Hasegawa	a et al.

REFERENCE DESIGNATION

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KEI EKENGE BEGIGNATION			<u> </u>	TI DOCUME	1410		
EXAMINER INITIAL		DOCUMENT NUMBER	DATE		NAME	CLASS/ SUBCLASS	FILING DATE
	A1	6,030,753	02/2000	Lin	****		

FOREIGN PATENT DOCUMENTS

NUMBER	DATE	COUNTRY	SUBCLA SS	YES	NO
Japanese Unexamined Patent Application Publication No. 8-7225	01/1996	Japan		х	
Japanese Unexamined Patent Application Publication No. 2001-13910	01/2001	Japan		x	
Japanese Unexamined Patent Application Publication No. 2001-256617	09/2001	Japan		x	
Japanese Unexamined Patent Application Publication No. 2000-163717	06/2000	Japan		х	
	Patent Application Publication No. 8-7225 Japanese Unexamined Patent Application Publication No. 2001-13910 Japanese Unexamined Patent Application Publication No. 2001-256617 Japanese Unexamined Patent Application Publication Publication Publication Publication	Patent Application Publication No. 8-7225 Japanese Unexamined Patent Application Publication No. 2001-13910 Japanese Unexamined Patent Application Publication Publication No. 2001-256617 Japanese Unexamined Patent Application Publication Publication Publication Publication Publication Publication	Patent Application Publication No. 8-7225 Japanese Unexamined Patent Application Publication No. 2001-13910 Japanese Unexamined Patent Application Publication Publication No. 2001-256617 Japanese Unexamined Patent Application Publication No. 2001-256617 Japanese Unexamined Patent Application Publication Publication	Japanese Unexamined Patent Application Publication No. 8-7225 Japanese Unexamined Patent Application Publication No. 2001-13910 Japanese Unexamined Patent Application Publication Publication No. 2001-256617 Japanese Unexamined Patent Application Publication No. 2001-256617 Japanese Unexamined Patent Application Publication Publication Publication Publication Publication	Japanese Unexamined Patent Application Publication No. 8-7225 Japanese Unexamined Patent Application Publication No. 2001-13910 Japanese Unexamined Patent Application Publication Publication No. 2001-256617 Japanese Unexamined Patent Application Publication No. 2001-256617 Japanese Unexamined Patent Application Publication Publication Publication Publication Publication

EXAMINER INITIAL	OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER	DATE CONSIDERED	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.